

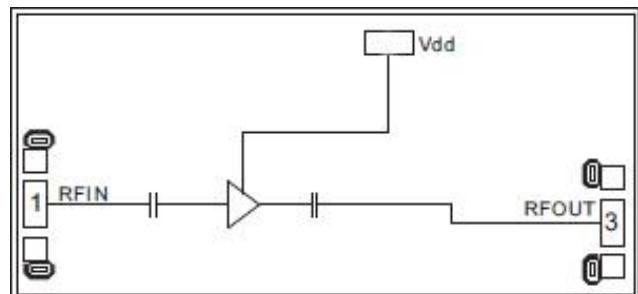


## GaAs MMIC LNA, 18-40GHz

### Features:

- Frequency: 18-40GHz
- Small Signal Gain: 9.5dB
- Noise Figure: 3.0dB typ. /3.2dB . max
- P-1dB: 12dBm
- Supplying: +5V/40mA
- 50Ohm Input/output
- 100% tested
- Chip Size: 1.85 x 1.6 x 0.09 mm

### Functional Diagram:



### General Description:

YTLA-1840D is a GaAs MMIC HEMT Self-biased, wideband Low Noise Amplifier Die Which perate between 18GHz~40GHz , with small signal gain value of 9.5dB, Noise Figure 3.0dB, Max. 3.2dB。It adopts use + 5V single supply。

Parameter <sup>1</sup>	
Max Drain Voltage	+7V
Max. input Power	+20dBm
Working Temperature	-55 ~ +85°C
Storage Temperature	-65 ~ +150°C

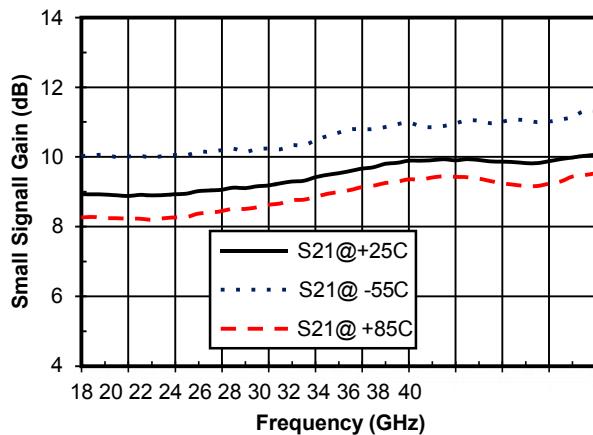
【1】 There is a risk of permanent damage over any of the above maximum limits.

Electrical Specifications( $T_A = +25^\circ\text{C}$ , $Vd=+5\text{V}$ )				
Paramter	Min.	Typ.	Max.	Unite
Frequency		18-40		GHz
Small Signal Gain	9	9.5	10	dB
Flatness		$\pm 0.5$		dB
Noise Figure	-	3.0	3.2	dB
P-1dB	-	12	-	dBm
Input return loss	17	20	-	dB
Output return loss	20	25	-	dB
Supply current		40		mA

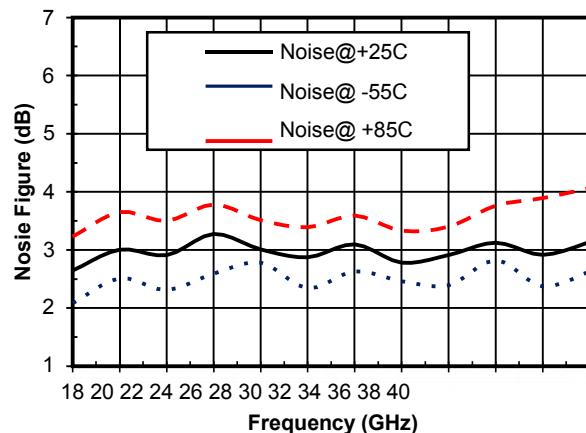
## GaAs MMIC LNA, 18-40GHz

Curves:

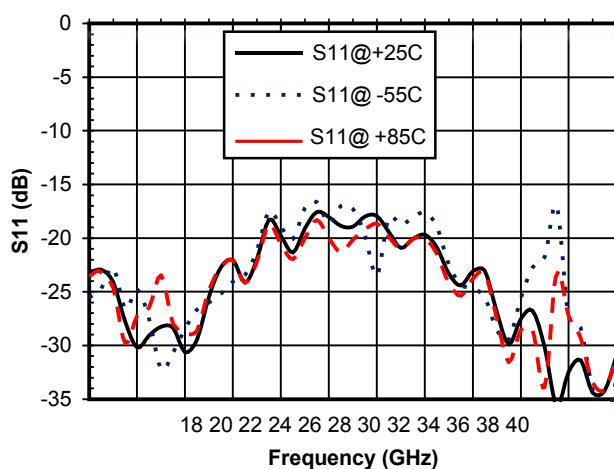
Gain vs. Frequency



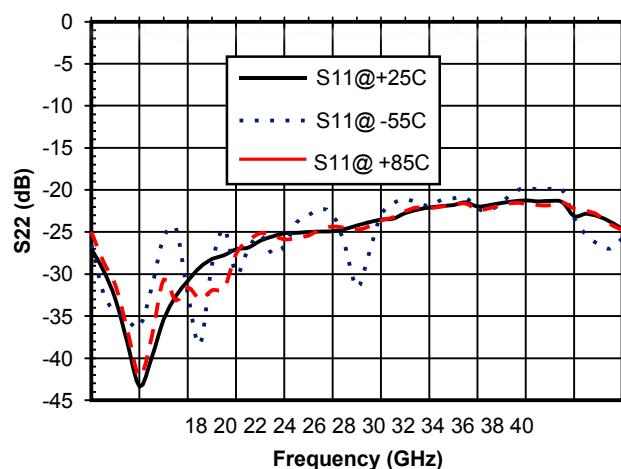
Noise Figure vs. Frequency



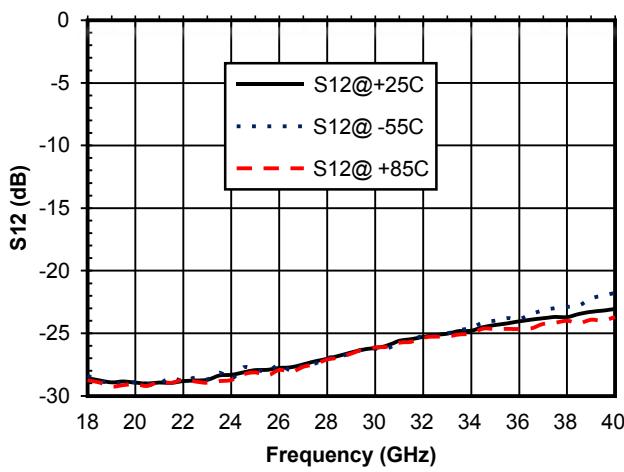
Input Return Loss vs. Freq.



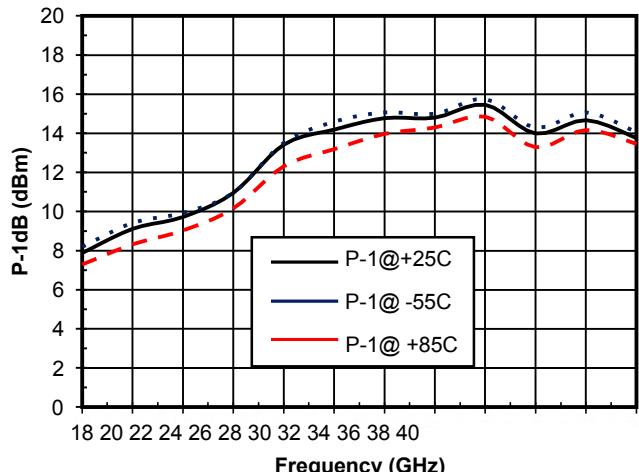
Output Return Loss vs. Freq.

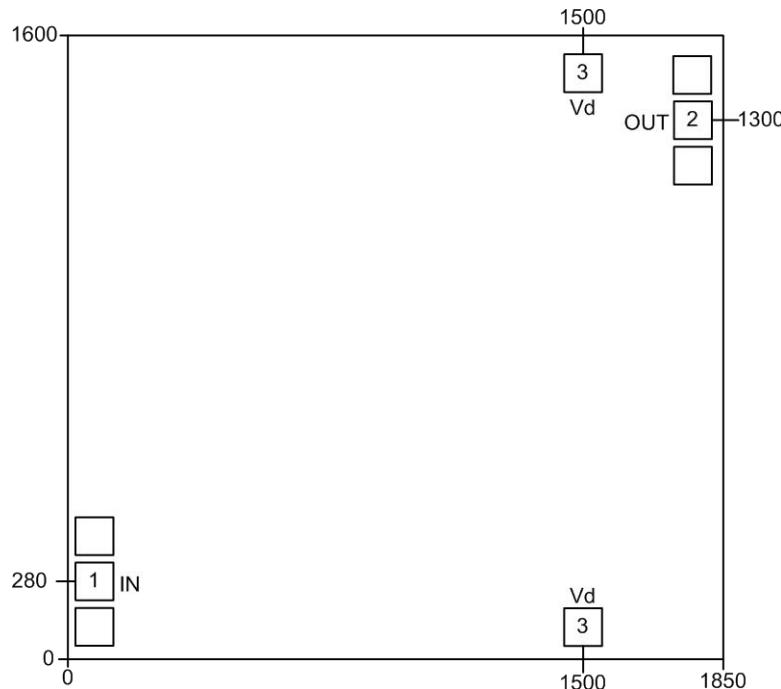


Isolation vs. Frequency



P-1dB vs. Frequency



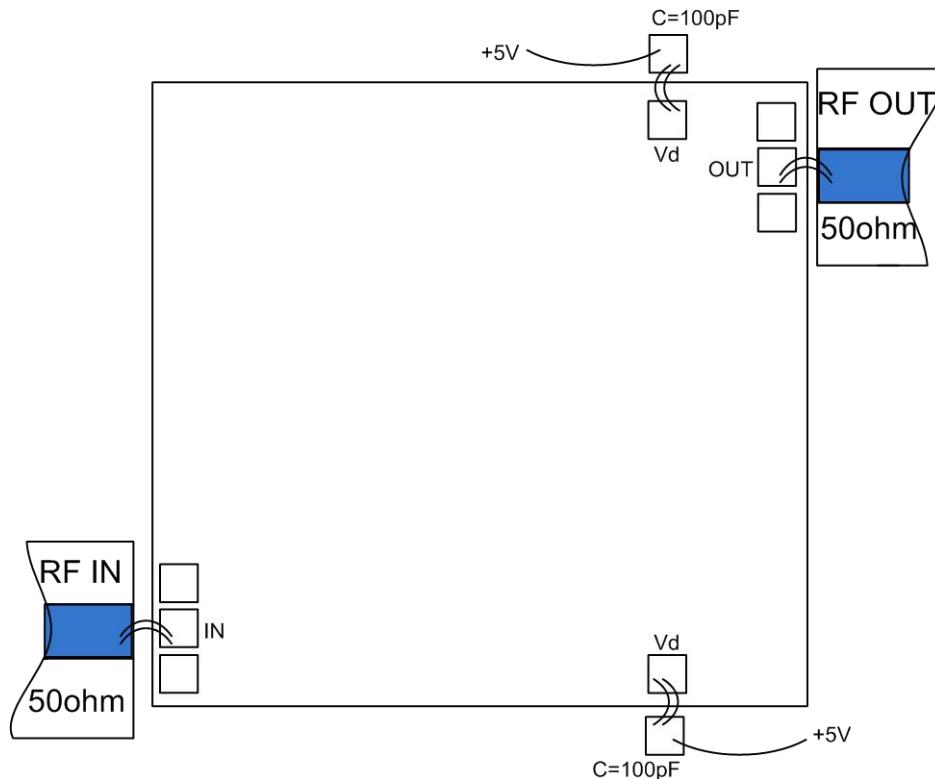
**GaAs MMIC LNA, 18-40GHz**
**Outline Drawing <sup>2</sup>**


【2】 $\mu$ m

Pad Descriptions			
Part No.	Function	Description	Circuit
1	RFIN	RF signal input, no straightening capacitor	RF IN
2	RFOUT	RF signal output, no straightening capacitor	RF OUT
3	VD	Amplifier drain bias, external 100pf bypass capacitance, single side power supply, only one side of the bonding vd .	Vdd
Die Bottom	GND	Die bottom must be connected to RF/DC ground.	GND

## GaAs MMIC LNA, 18-40GHz

### Assembly



【3】single side power supply, only one side of the bonding vd。

### Handling Precautions

- All bare die are placed in either Waffle or Gel based ESD protective containers, stored in a dry nitrogen environment.
- Handle the chips in a clean environment. DO NOT attempt to clean the chip using liquid cleaning systems.
- Follow ESD precautions to protect against ESD strikes.
- Handle the chip along the edges with a vacuum collet or with a sharp pair of bent tweezers. The surface of the chip has fragile air bridges and should not be touched with vacuum collet, tweezers, or fingers.
- The chip is back-metallized and can be die mounted with AuSn eutectic preforms or with electrically conductive epoxy. The mounting surface should be clean and flat.
- temperature of 265 ° C. When hot 90/10 nitrogen/hydrogen gas is applied, tool tip temperature should be 290 ° C. DO NOT expose the chip to a temperature greater than 320 ° C for more than 20 seconds. No more than 3 seconds of scrubbing should be required for attachment
- Apply a minimum amount of epoxy to the mounting surface so that a thin epoxy fillet is observed around the perimeter of the chip once it is placed into position. Cure epoxy per the manufacturer's schedule. .

Ball bonds should be made with a force of 40–50 grams and wedge bonds at 18–22 grams. All bonds should be made with a nominal stage temperature of 150 ° C. A minimum amount of ultrasonic energy should be applied to achieve reliable bonds.